



IN THE UNITED STATE PATENT AND TRADEMARK OFFICE

In re application of : Attn: **BOX MISSING PARTS**
Takayuki SAITO et al. : Docket No. 2003_1585A
Serial No. 10/695,826 :
Filed October 30, 2003 :
SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

VERIFICATION

Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

Sir:

I, Tetsuya Hirosawa, declare and say:

that I am thoroughly conversant in both the Japanese and English languages;

that I am presently engaged as a translator in these languages;

that the attached document represents a true English translation of the above-identified Japanese application entitled "SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD".

I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Signed this 21st day of June, 2004.


TRANSLATOR